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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Wenling Wang, et al.
Serial No. : To Be Assigned Art Unit : To Be Assigned
Filed : Herewith Examiner : To Be Assigned
For : HEAT TREATMENT APPARATUS, CALIBRATION METHOD FOR
TEMPERATURE MEASURING SYSTEM OF THE APPARATUS,
AND HEAT TREATMENT SYSTEM

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to the duty of disclosure under 37 C.F.R. § 1.56, Applicants are enclosing an Information Disclosure Citation Form (PTO-1449).

These documents were cited by the Examiner and the Applicants during prosecution of the parent application 09/909,861, filed July 23, 2001. No copies of the documents are necessary in accordance with 37 C.F.R. §1.98(d).

Applicants respectfully ask that each of these documents be made officially of record in this application, and that a listing of the same appear on the face of any patent which may issue from this application.

Respectfully submitted,
SMITH, GAMBRELL & RUSSELL, LLP

By: 

Michael A. Makuch, Reg. No. 32,263
1850 M Street, N.W., Suite 800
Washington, D.C. 20036
Telephone: (202) 263-4300
Facsimile: (202) 263-4329

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